PATENT COOPERATION TREATY

From the INTERNATIONAL SEARCHING AUTHORITY

Japan

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PCT

WRITTEN OPINION OF THE INTERNATIONAL SEARCHING AUTHORITY

(PCT Rule 43bis.1)

Date of mailing (day/month/year)

11.1.2005

		(aay/monin/year)	11. 1. 2000	
Applicant's or agent's file reference	pplicant's or agent's file reference FOR FURTHER ACTION		ACTION	
10003410WO01 See paragraph 2 below		See paragraph 2 below		
International application No.	International filing date (day/month/year)		Priority date (day/month/year)	
PCT/JP2004/015295	08.10.2004		09.10.2003	
International Patent Classification (IPC) Int.Cl 7 H01L 29/786, H0			C08F 220/14	
Applicant				
CANON KABUSH	IKI KAISHA			

1.	. This opinion contains indications relating to the following items:				
	V	Box No. I	Basis of the opinion		
		Box No. II	Priority		
		Box No. III	Non-establishment of opinion with reg	ard to novelty, inventive step and industrial app	licability
		Box No. IV	Lack of unity of invention		
	1	Box No. V	Reasoned statement under Rule 43bis.16 citations and explanations supporting statement and explanations supporting statement and explanations supporting statement and explanations are statement under Rule 43bis.16 citations and explanations are statement under Rule 43bis.	a)(i) with regard to novelty, inventive step or indu such statement	strial applicability;
		Box No. VI	Certain documents cited		
•		Box No. VII	Certain defects in the international app	olication	l
		Box No. VIII	Certain observations on the internation	al application	·
2.	If a content other opini If this a write PCT/	national Prelimin than this one to ons of this Inter s opinion is, as p tten reply togeth ISA/220 or befor urther options, se	mational preliminary examination is material preliminary examination is material Examining Authority ("IPEA") excepte the IPEA and the chosen IPEA has mational Searching Authority will not be provided above, considered to be a writter	opinion of the IPEA, the applicant is invited to s before the expiration of 3 months from the date of	ooses an Authority bis(b) that written
		mailing address		Authorized officer	

The same and maining address of the ISAMP	!	4M 3123
Japan Patent Office	Sonoko Miyazaki	
3-4-3, Kasumigaseki, Chiyoda-ku, Tokyo 100-8915, Japan	Telephone No. +81-3-3581-1101 Ext. 3	462





International application No.

PCT/JP2004/015295

Box	No. I	Basis of the opinion
1.	which it	ard to the language, this opinion has been established on the basis of the international application in the language in was filed, unless otherwise indicated under this item. is opinion has been established on the basis of a translation from the original language into the following language , which is the language of a translation furnished for the purposes of international search (under les 12.3 and 23.1(b)).
2.		ard to any nucleotide and/or amino acid sequence disclosed in the international application and necessary to the execution, this opinion has been established on the basis of: material a sequence listing table(s) related to the sequence listing
	b. format	of material in written format in computer readable form
		filing/furnishing contained in the international application as filed. filed together with the international application in computer readable form. furnished subsequently to this Authority for the purposes of search.
3.	— file	addition, in the case that more than one version or copy of a sequence listing and/or table relating thereto has been ad or furnished, the required statements that the information in the subsequent or additional copies is identical to that the application as filed or does not go beyond the application as filed, as appropriate, were furnished.
4.	Addition	nal comments:
•		•



International application No.
PCT/JP2004 / 015295

Box No. II Priority
1. The following document has not yet been furnished:
copy of the earlier application whose priority has been claimed (Rules 43bis.1 and 66.7(a)).
translation of the earlier application whose priority has been claimed (Rules 43bis.1 and 66.7(b)).
Consequently it has not been possible to consider the validity of the priority claim. This opinion has nevertheless been established on the assumption that the relevant date is the claimed priority date.
2. This opinion has been established as if no priority had been claimed due to the fact that the priority claim has been found invalid (Rules 43bis.1 and 64.1). Thus for the purposes of this opinion, the international filing date indicated above is considered to be the relevant date.
3. Additional observations, if necessary:
P1:Application number JP 2003-351159 (Date of Filing:2003.10.09) P2:Application number JP 2004-264499 (Date of Filing:2004.09.10)
The subject matter of claims 5-18,23-26 is supported by P2, but it is not supported by P1.
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International application No.
PCT/JP2004/ 015295

Box No. V Reasoned statement under Rule 43bis.1(a)(i) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement

1. Statement			
Novelty (N)	Claims	1-4,8-15,19-27	YES
	Claims	5-7,16-18	NO
Inventive step (IS)	Claims	1-4,8-10,12-14,19-27	YES
	Claims	5-7,11,15-18	NO
Industrial applicability (IA)	Claims	1-27	YES
	Claims		NO

2. Citations and explanations

D1:JP 2004-165427 A(KONIKA MINOLTA HOLDINGS, INC.)

2004.06.10, whole document, Figs.1-3

D2:EP 1385220 A2(PIONEER CORPORATION)

2004.01.28, whole document, Figs. 1-8

[Claims 1-4,8-10,12-14,19-27]

The subject matter of claims 1-4,8-10,12-14,19-27 is neither disclosed in any of the documents cited in the ISR nor obvious to a person skilled in the art.

[Claims 5-7,16-18]

The subject matter of claims 5-7,16-18 does not appear to be novel with respect to the document D1.

The subject matter of claims 5-7,16-18 is disclosed in the document D1.

[Claims 11,15]

The subject matter of claims 11,15 does not appear to involve an inventive step in view of the document D1 cited in the ISR and the document D2 cited in the same. The document D2 discloses that a gate electrode, a gate insulating film, one of

source/drain electrodes, an organic semiconductor and the other of the source/drain electrodes are provided on the substrate in this order.